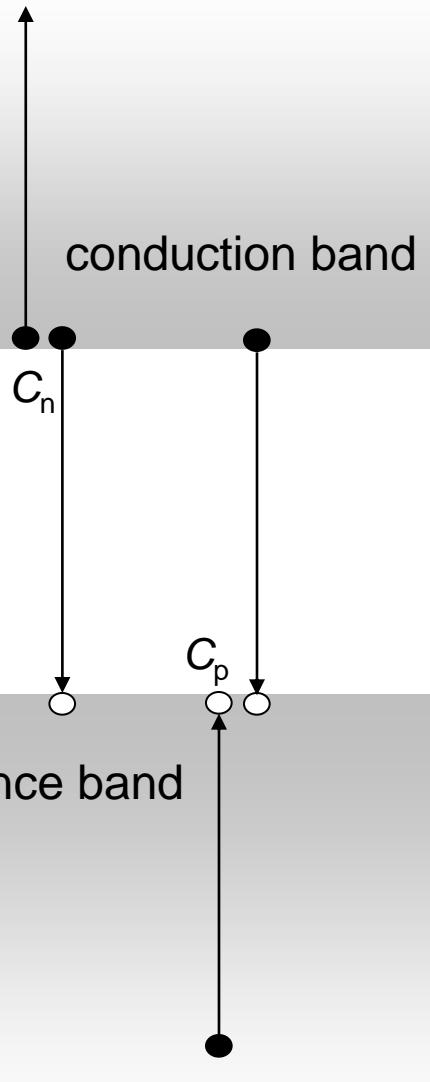
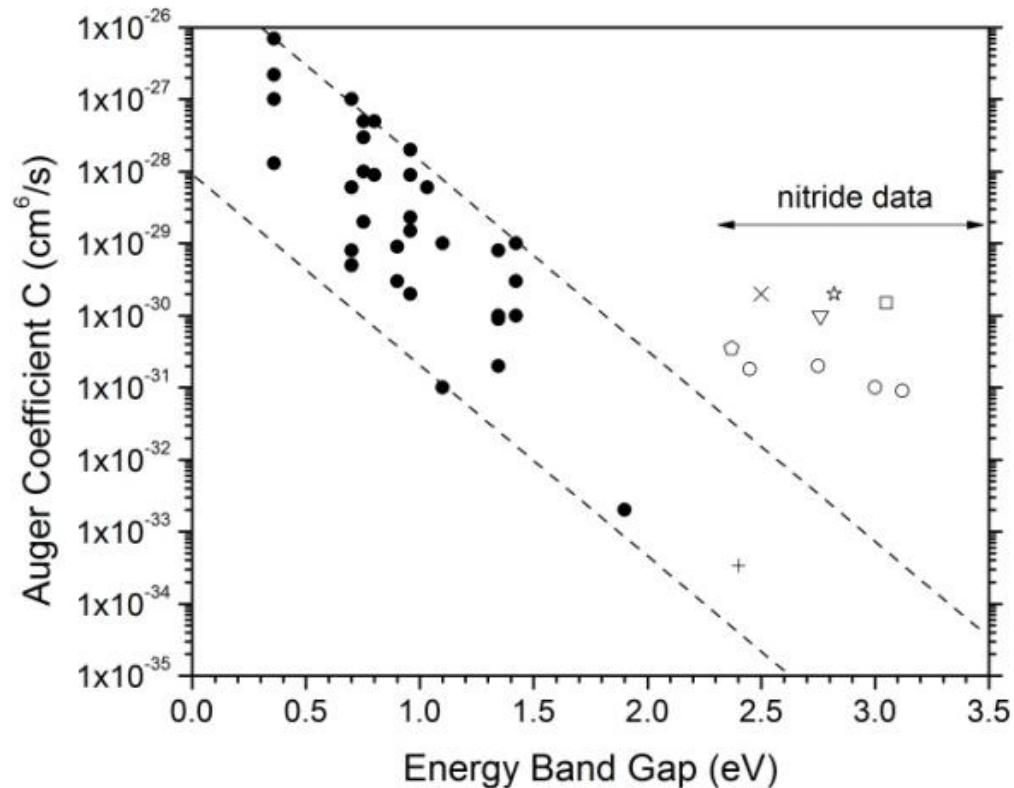


# Auger Recombination



$$R_{\text{Auger}} = (C_n n + C_p p)(np - n_i^2)$$



How to determine  $C$  for InGaN QWs ?

# Direct Experimental Evidence

PRL 110, 177406 (2013)

PHYSICAL REVIEW LETTERS

week ending  
26 APRIL 2013

## Direct Measurement of Auger Electrons Emitted from a Semiconductor Light-Emitting Diode under Electrical Injection: Identification of the Dominant Mechanism for Efficiency Droop

Justin Iveland,<sup>1</sup> Lucio Martinelli,<sup>2</sup> Jacques Peretti,<sup>2</sup> James S. Speck,<sup>1</sup> and Claude Weisbuch<sup>1,2,\*</sup>

<sup>1</sup>Materials Department, University of California, Santa Barbara, California 93106, USA

<sup>2</sup>Laboratoire de Physique de la Matière Condensée, CNRS-Ecole Polytechnique, 91128 Palaiseau Cedex, France

(Received 25 December 2012; published 25 April 2013)

We report on the unambiguous detection of Auger electrons by electron emission spectroscopy from a cesiated InGaN/GaN light-emitting diode under electrical injection. Electron emission spectra were measured as a function of the current injected in the device. The appearance of high energy electron peaks simultaneously with an observed drop in electroluminescence efficiency shows that hot carriers are being generated in the active region (InGaN quantum wells) by an Auger process. A linear correlation was measured between the high energy emitted electron current and the “droop current”—the missing component of the injected current for light emission. We conclude that the droop phenomenon in GaN light-emitting diodes originates from the excitation of Auger processes.

- hot Auger electrons detected
- magnitude of effect on droop unclear ( $C = ?$ )
- disputed by other authors based on fast p-side carrier relaxation

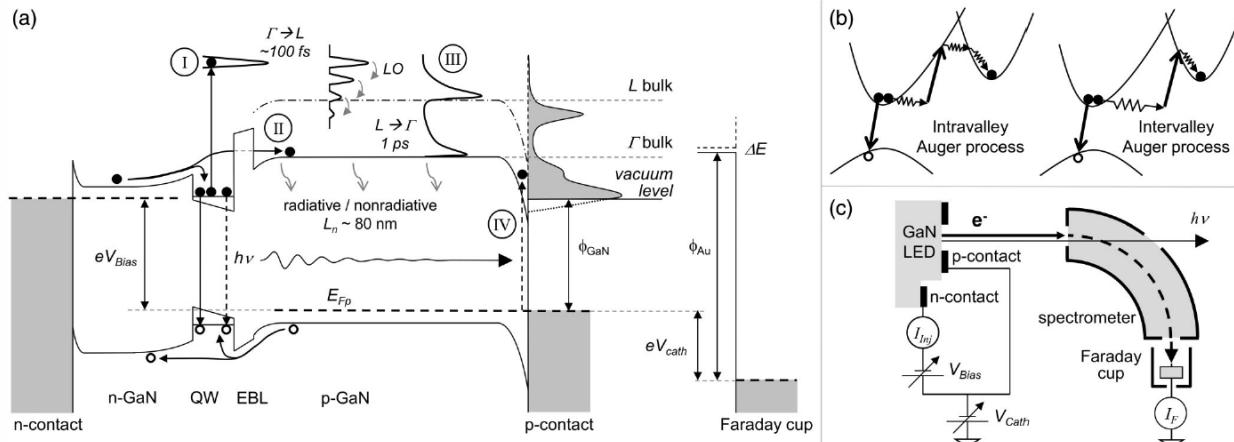


FIG. 1. (a) Energy levels for a biased LED structure emitting electrons in vacuum. (b) Schematics of hot electron generation into the  $L$  valley by an  $e\text{eh}$  Auger process: Left, the Auger electron is created in the  $\Gamma$  band (intravalley process) and transferred to the  $L$  valley; right, the Auger electron is created in the  $L$  valley (intervalley process). (c) Schematics of the electron energy analysis setup.

# Experimental Results for C of InGaN QWs

APPLIED PHYSICS LETTERS **106**, 101101 (2015)



## On the uncertainty of the Auger recombination coefficient extracted from InGaN/GaN light-emitting diode efficiency droop measurements

Joachim Piprek,<sup>1,a)</sup> Friedhard Römer,<sup>2</sup> and Bernd Witzigmann<sup>2</sup>

<sup>1</sup>NUSOD Institute LLC, Newark, Delaware 19714-7204, USA

<sup>2</sup>Department of Electrical Engineering, University of Kassel, 34121 Kassel, Germany

(Received 23 December 2014; accepted 28 February 2015; published online 10 March 2015)

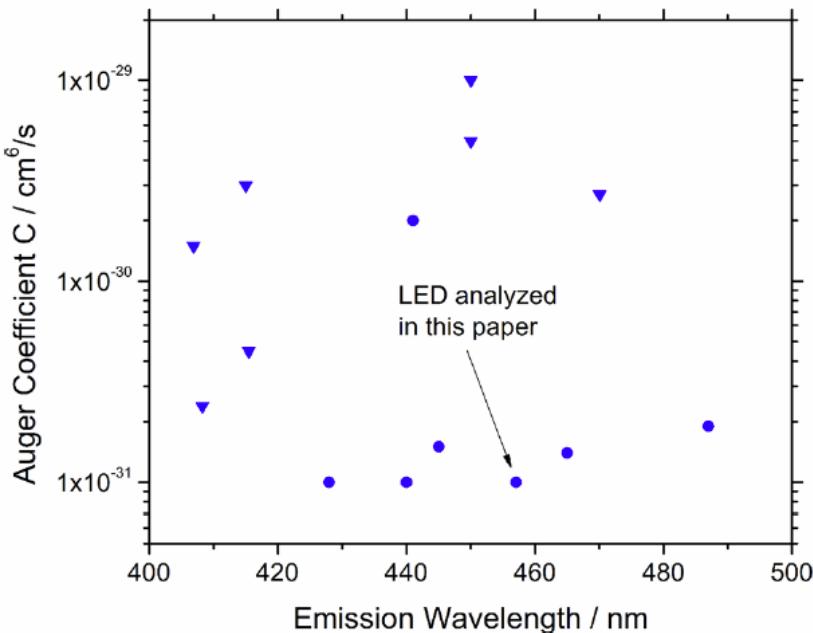


FIG. 1. Published Auger coefficients  $C$  extracted from measurements on devices with InGaN active layers of different emission wavelength (circles—single active layer, triangles—multiple quantum wells).

TABLE I. Recombination parameter sets extracted from the measurements in Fig. 2 using different models.

Model	$A/10^6 \text{s}^{-1}$	$B/10^{-12} \text{cm}^3/\text{s}$	$C/10^{-31} \text{cm}^6/\text{s}$
ABC model	2.6	3.0	1.0
ABC model with $n = 2p$	3.9	1.5	0.16
APSYS	14 <sup>a</sup>	(17 <sup>a</sup> )	2.5 <sup>a</sup>
Quatra/Cels	3.1	4.1 <sup>b</sup>	1.7 <sup>b</sup>
Quatra/Cels (hot carriers)	3.1	4.1 <sup>b</sup>	0.8 <sup>b</sup>
Quatra/Cels (no polarization)	5.9	17.7	7.0

<sup>a</sup>Electron-hole separation is considered separately.

<sup>b</sup>Values  $B(i)$  and  $C(i)$  given at  $i_{\text{heat}} = 5 \text{ A/cm}^2$ .

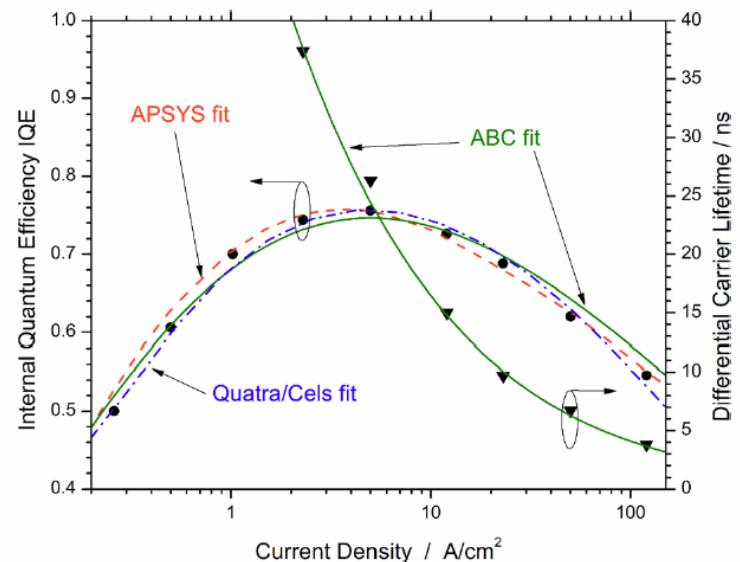
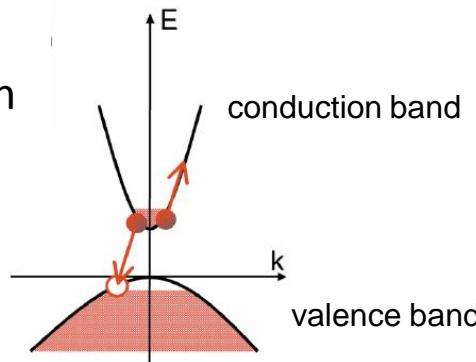


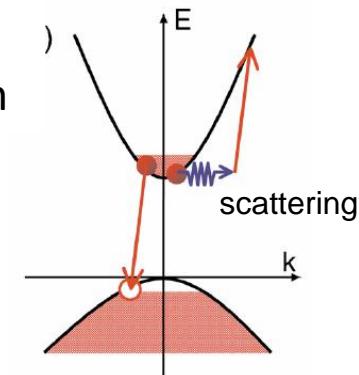
FIG. 2. Internal quantum efficiency IQE and differential carrier lifetime as function of current density (symbols—measurements, lines—modeling).

# Theoretical Results for C in InGaN

direct Auger recombination



indirect Auger recombination



atomistic model calculations of the Auger parameter

$C = 3 \times 10^{-34} \text{ cm}^6/\text{s}$  (QW, direct) [Hader et al., APL 2008] KP band structure

$C < 2 \times 10^{-30} \text{ cm}^6/\text{s}$  (bulk, direct) [Delaney et al., APL 2009] inter conduction-band transitions

$C < 5 \times 10^{-33} \text{ cm}^6/\text{s}$  (bulk, direct) [Bertazzi et al., APL 2010] inter conduction-band transitions

$C < 2 \times 10^{-31} \text{ cm}^6/\text{s}$  (bulk, indirect) [Kioupakis et al., APL 2011] indirect

$C < 1 \times 10^{-31} \text{ cm}^6/\text{s}$  (bulk, indirect) [Bertazzi et al., APL 2012] indirect

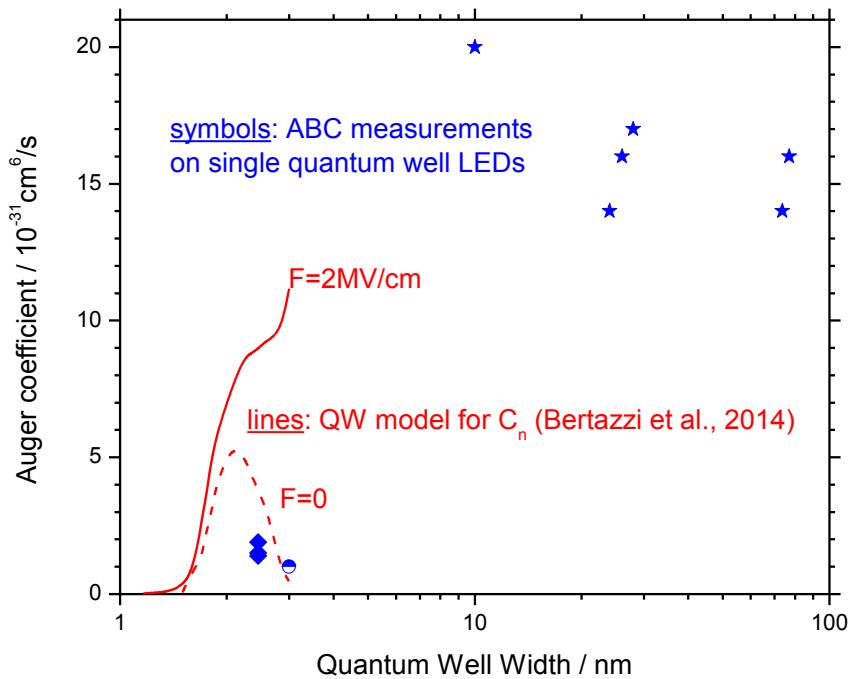
$C < 9 \times 10^{-31} \text{ cm}^6/\text{s}$  (QW, direct) [Vaxenburg et al., APL 2013] KP, zinc-blende

$C < 5 \times 10^{-31} \text{ cm}^6/\text{s}$  (QW, direct) [Bertazzi et al., APL 2013] strong d-dependence

$C < 7 \times 10^{-31} \text{ cm}^6/\text{s}$  (QW, direct, 2MV/cm) [Bertazzi et al., NUSOD 2014]

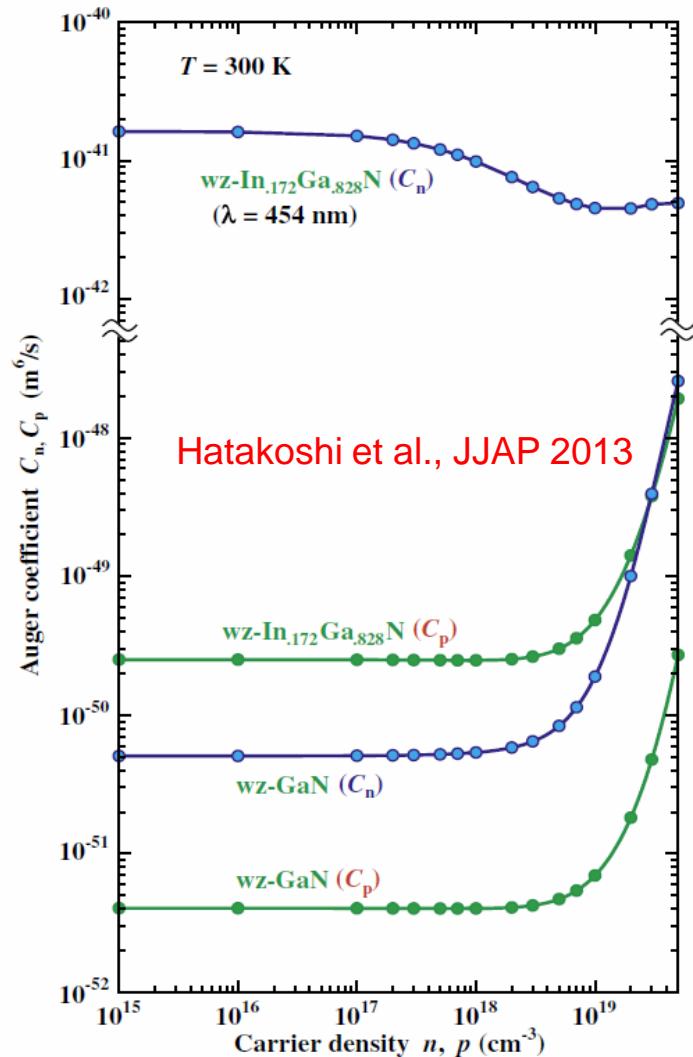
# Theoretical Sensitivities of the Auger Coefficient

quantum well thickness & electric field



- strong dependence on QW width and field
- C varies with carrier density ( $C_n^3$  not correct)

carrier density (bulk)



# What do we need to do ?

---

Develop theory for Auger recombination  
in InGaN and AlGaN quantum wells  
which includes the influence of

- *indirect transitions*
- *polarization field*
- *composition*
- *thickness & shape*
- *non-uniformities*